



Attorney Docket No. 0756-7176

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Koji DAIRIKI

Serial No. 10/625,737

Filed: July 24, 2003

For: SEMICONDUCTOR DEVICE

MANUFACTURING METHOD, HEAT

TREATMENT APPRATUS AND

HEAT TREATMENT METHOD

) Group Art Unit: 2822

) Examiner: Maria F. Guerrero

) CERTIFICATE OF MAILING

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) 2006.

) Adeline M. Stamper

AMENDMENT

Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated December 29, 2005, please consider the following amendments and remarks in connection with the above-identified application.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 8 of this paper.